

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

METHOD FOR UNIFORM REACTIVE ION ETCHING OF DUAL
PRE-DOPED POLYSILICON REGIONS

Application Number :

Confirmation Number:

First Named Applicant: Joyce Liu

Attorney Docket Number: FIS920030338US1

Art Unit:

Examiner:

Search string: (5912187 or 6322714 or 6352934 or 6399432 or 6458646 or 20030186492).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|-------------------|------|-------|----------|
| LT | 1 | 5912187 | 1999-06-15 | Blasko et al. | | 438 | 719 |
| LT | 2 | 6322714 | 2001-11-27 | Nallan et al. | B1 | 216 | 67 |
| LT | 3 | 6352934 | 2002-03-05 | Lee | B1 | 438 | 704 |
| LT | 4 | 6399432 | 2002-06-04 | Zheng et al. | B1 | 438 | 232 |
| LT | 5 | 6458646 | 2002-10-01 | Divakaruni et al. | B1 | 438 | 241 |

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

| init | Cite.No. | Pub. No. | Date | Applicant | Kind | Class | Subclass |
|------|----------|-------------|------------|--------------|------|-------|----------|
| LT | 1 | 20030186492 | 2003-10-02 | Brown et al. | A1 | 438 | 200 |

Signature

Examiner Name

Date

Charles

9/9/04